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Bib Data Sheet

CONFIRMATION NO. 5338

SERIAL NUMBER 10/648,399	FILING DATE 08/27/2003 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. HIRA.0122
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

none / *A/G*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

~~A/G~~ JAPAN 2002-254628 08/30/2002

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 11/19/2003

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	4	3	3
Verified and Acknowledged	<i>L.S.</i> Examiner's Signature	Initials			

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TITLE  
Method for converting and purifying materials for modifying surfaces of semiconductor nanoparticles

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